



**ELECTRONIC COPY**

## LABORATORY GROWN DIAMOND REPORT

August 3, 2024	
IGI Report Number	LG646446976
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUT CORNERED RECTANGULAR MODIFIED BRILLIANT
Measurements	9.08 X 6.28 X 4.25 MM

## GRADING RESULTS

Carat Weight	2.10 CARATS
Color Grade	E
Clarity Grade	VS 1

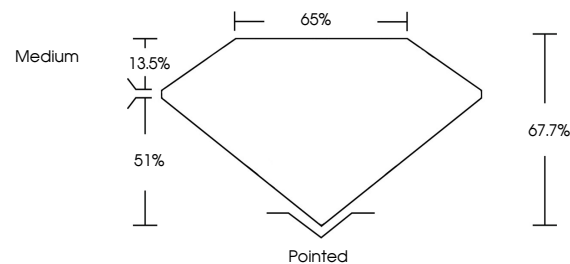
### ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	13 LG646446976

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

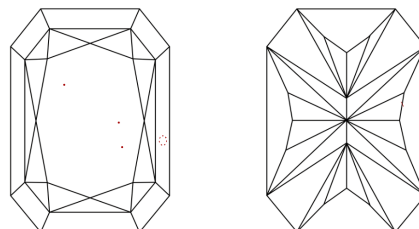
LG646446976  
Report verification at [igi.org](https://igi.org)

## PROPORTIONS



Sample Image Used

## CLARITY CHARACTERISTICS



## KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

## CLARITY

IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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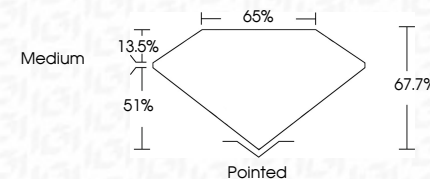
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**www.igi.org**

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August 3, 2024	GI Report No 1G6A446976	2.10 CARATS
CU CORNERED RECT, MODIFIED BRILLIANT		
0.08 X 0.08 X 0.28 X 4.25 MM		
Carat Weight	VS 1	
Color Grade	67.7%	
	65%	
	Medium	
Clarity Grade		
Depth		
Table		
Grade		
Culet		
Polish		
Symmetry		
Fluorescence		
Report (s)		
sent 1G6A446976		

**Comments:**  
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